











JSM-IT300

New Generation JEOL Scanning Electron Microscope

- Extended low vacuum capability as standard [650 Pa]
- · New charge-free scanning modes
- New faster, quieter, high-load stage [2 kg tilted to 90°]
- Even more accessory ports
 (EDS/WDS/EBSD working distance of 10 mm)
- High resolution frame store (5120 \times 3920) as standard
- · High reliability

